PATENT Attorney Docket No. 0175.0005

Serial No. 10/015,063 **Filed:** December 11, 2001

Title: METHOD FOR LITHOGRAPHIC

PROCESSING ON MOLECULAR MONOLAYER AND MULTILAYER

THIN FILMS

Applicants: Heath et al. Group Art Unit No. 2818 Examiner: Thao P. Le

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop RCE Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR TWO-MONTH EXTENSION OF TIME

Sir:

Applicants hereby request a two-month extension of time within which to respond to the OFFICE ACTION dated May 30, 2003, and the ADVISORY ACTION dated September 23, 2003. The extension will give applicants until October 30, 2003 to file a response thereto, said response being the REQUEST FOR CONTINUED EXAMINATION (RCE) filed concurrently herewith.

Applicants also enclose herewith a check in the amount of \$1,190.00 to cover the cost of the government fees associated with the extension request and the RCE filing fee. Please charge any deficiency in the enclosed fees or credit any overpayments to Deposit Account No. 50-1811.

Respectfully submitted,

Dated: October 28, 2003

11/04/2003 AWDNDAF1 00000070 10015063

02 FC:1252 420.00 OP

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